Exam.Code:0932 Sub. Code: 6636

2054

B.E. (Electronics and Communication Engineering) Eighth Semester

EC-814: MEMS and Microsystems

Time allowed: 3 Hours

Max. Marks: 50

NOTE: Attempt <u>five</u> questions in all, including Question No. I which is compulsory and selecting two questions from each Unit.

x-x-x

- I. Answer the following:a) How micro sensor works? b) What is Lucrative Revenue Prospects for Miniaturized Industrial Products? c) Why Scaling required? d) Give role of High-K. e) Describe IC packaging process. (5x2)UNIT - I II. a) What are short channel effect? How they can be minimized. b) What is full scaling? Describe its features. (2x5)III. a) Explain process of scaling in electricity. b) Why high-K materials used in MEMS devices? (2x5)IV. a) Compare the properties of Silicon materials with AlAs. b) How packaging materials are categorized? Give their prime features. (2x5)UNIT - II V. a) What is oxidation? Explain oxidation process. b) How web etching take place? Describe it chemical reactions. (2x5)VI. a) Explain chemical vapor deposition process. b) Derive Fick's one-dimensional diffusion equation. (2x5)
- VII. Write a note on:
 - a) Surface micromachining.
 - b) Computer aided design.

(2x5)